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ATTORNEY'S DOCKET NO. V00077.70221.US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Steven R. Walther  
Serial No: Reissue Application for U.S. Patent 6,323,497  
Filed: Herewith  
For: METHOD AND APPARATUS FOR CONTROLLING ION IMPLANTATION  
DURING VACUUM FLUCTUATION  
Examiner: Not Yet Assigned  
Art Unit: Not Yet Assigned

MAIL STOP REISSUE  
Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

REQUEST FOR ABSTRACT OF TITLE

Please prepare a certified Abstract of Title for U.S. Patent No. 6,323,497 to be placed in the official file of the Reissue Application which is filed herewith.

Please charge the fee required by 37 C.F.R. §1.19(b)(4) to Deposit Account No. 50-0896. A duplicate of this request is attached.

Respectfully submitted,

By: William R. McClellan  
Robert E. Hunt, Reg. No. 39,231  
William R. McClellan, Reg. No. 29,409  
WOLF, GREENFIELD & SACKS, P.C.  
600 Atlantic Avenue  
Boston, MA 02210  
(617)720-3500

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